

IMEC320.001APC

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PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant	:	De Keersmaecker, et al.
Appl. No.	:	Unassigned
Filed	:	Herewith
For	:	THE USE OF MICROELECTRONIC STRUCTURES FOR PATTERNED DEPOSITION OF MOLECULES ONTO SURFACES
Examiner	:	Unassigned
Group Art Unit	:	Unassigned

**PRELIMINARY AMENDMENT**

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Prior to the examination of the above-identified application on the merits, please amend the application as follows.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 4 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.